Interaction between graphene and SiO₂ surface

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Abstract

With first-principles DFT calculations, the interaction between graphene and SiO₂ surface has been analyzed by constructing the different configurations based on α -quartz and cristobalite structures. The single layer graphene can stay stably on SiO₂ surface is explained based on the general consideration of configuration structures of SiO₂ surface. It is also found that the oxygen defect in SiO₂ surface can shift the Fermi level of graphene down which opens out the mechanism of hole-doping effect of graphene absorbed on SiO₂ surface observed in experiments.

Introduction

Graphene, which is a monolayer of carbon atoms with honeycomb lattice¹, has attracted enormous attention² due to the fascinating physical properties³, such as abnormal quantum Hall effects⁴ and massless Dirac fermions⁵, which are ascribed to the liner dispersion near Dirac points in the *k* space. In additional, with extremely high mobility of carriers, graphene is expected to be the kernel material in the next generation of carbon-based nanoelectronics⁶⁻⁸. However, the prominent electronic properties of graphene are very sensitive to the change of external conditions⁸⁻¹⁰. The electronic states near Dirac points are modulated easily due to the absorption of some molecules^{11, 12}, structural corrugation^{13, 14} and interaction with substrate surfaces^{15, 16}. Obviously, this issue is critical to the wider electronic-device applications, such as field effect transistors. With the view of two-dimensional materials as a transport layer in the switching devices, the interaction between graphene with the dielectric layer is important. The change of structural and electronic properties of graphene due to the interaction deserves to be analyzed.

In present, two surfaces (SiC and SiO₂) have drawn a great attention. Graphene can be grown epitaxially on SiC substrate by high temperature annealing. Therefore, the interaction between graphene and SiC surface have been largely investigated¹⁶⁻¹⁹. The other one is SiO₂ surface which is the thin oxide layer of Si substrate and widely

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used as an insulating medium for Si-based device design^{4, 5, 8, 9, 20}. After the graphene is discovered on SiO₂ surface by optical measurement, various experiments about graphene sheets and nanoribbons²¹, including the device fabrication and the measurement of fundamental properties, have been taken on SiO₂ substrate^{4, 5, 8, 9, 20}. The properties of graphene absorbed on SiO₂ are possible to be modulated has been reported by many experiments^{4, 8, 22, 23}. The stable gate-controlled conduction has proven that the few-layer graphene can be stable on SiO_2 surface²⁰. In the seed paper of Novoselov et al., the electronic measurement showed that single layer graphene on SiO_2 surface is possible to be doped chemically⁵. In the experiment of Tomero et al., the graphene was found to be initially p-type and changed to be n-type after annealing at 200 °C in vacuum for the graphene devices fabricated on Si/SiO₂ substrate²⁴. With scanning probe microscopy, Ishigami et al. considered that graphene sheet just partially conformed to the SiO₂ substrate²². The Raman spectroscopy observed the spatially inhomogeneous doping effect of graphene supported by SiO_2 substrate²³. By anneal experimental, thermal annealing can induce increased coupling between graphene and SiO₂ surface and the absorbed oxygen is activated to accept the charge from graphene^{25, 26}. The theoretical calculation will play an important role to elucidate the micromechanism of interface between graphene and SiO₂ and help to explain the different phenomena in the experiments.

Kang et al. considered that graphene stayed on O-polar, Si-polar and the partially hydrogenated Si-polar α -quartz (0001) surface²⁷. They found that free-standing graphene could stay on Si-terminated surface. The electronic properties of graphene near Dirac points were modified obviously on O-polar and the partially hydrogenated Si-polar surface. Shemella et al. analyzed O-polar surface and found that the π electronic properties of graphene were destroyed fully²⁸. With hydrogen termination, graphene can freely stand on the surface. Hossain et al. found that graphene was adsorbed on specific sites of O-terminated surface and the charge transferred from graphene to the O (or Si)-terminated surface²⁹. Interestingly, Nguyen et al. found the O-termination surface could be reconstructed and thus graphene could freely stand on O-polar surface³⁰. The linear dispersion of π electrons was retained with a small band gap at the Dirac point and the charge transfer didn't found. Evidently, though many theoretical calculations have been performed to consider the interaction between graphene and SiO₂ surfaces, the results from different theoretical studies seem to be not consistent fully. There is not an explicit conclusion that can give a clear physical insight into the interaction and explain the experimental phenomena.

In this work, we analyze the interaction between graphene and SiO₂ surface by constructing the models based on α -quartz and cristobalite structures. SiO₂ surface from Si/SiO₂ involves a numerous number of configurations due to the amorphous nature. This results in that the atomic detail at the interface between graphene and SiO₂ is difficult to simulate. Thus, in order to consider the interaction at the interface, some typical local atomic configurations need to analyze to elucidate the micro-mechanism of interaction. In the previous theoretical study, the different configurations were not considered in detail. We systematically considered the different cases for the interaction, including the Si-polar surface with two dangling

bonds per surface Si atom, Si-polar with one dangling bond per surface Si atom, O-polar surface, Si-adsorbed surface, O-adsorbed surface, reconstructed O-polar surface and surface with defects. Based on the analysis of different configurations, we explain the reason why single layer graphene can stay stably on SiO₂ surface and the charge distribution of the graphene absorbed on SiO₂ is inhomogeneous. We also find that the oxygen defect in SiO₂ surface results in the hole-doping phenomenon of graphene absorbed on SiO₂ surface.

Structures and Method

1. Model Structures

The interaction between graphene and SiO₂ surfaces is simulated using the repeated-slab model. In order to avoid the spurious vertical coupling effect, the vacuum separation is set to be more than 15 Å. In the present work, both structures (α -quartz and cristobalite) are used to construct the surface of SiO₂ For α -quartz structure, (0001) surface is chosen to simulate the interaction. Seven layers of silicon dioxide with H-passivated bottom surface are used in order to eliminate the effect of interaction of both surfaces. For the 1×1 surface of α -quartz, the 2×2 cell of graphene can be matched properly with small difference of lattice constants. Thus, both oxygen (O)-terminated and silicon (Si)-terminated 1×1 surfaces are used to model the interaction with graphene. In order to simulate the case of oxygen (or silicon) absorbed SiO₂ surface, the 2×2 supercell is constructed to interact with one layer of graphene with 4×4 cell (32 carbon atoms). In order to simulate other configurations of SiO₂ surface, the (111) surface of cristobalite is adopted to model the interaction with graphene layer, though cristobalite is a high-temperature polymorph of SiO₂. As same as the α -quartz (0001) surface, the lattice constant of 1×1 surface can match properly with that of 2×2 cell of graphene. Twelve layers of silicon dioxide are used to eliminate the coupling effect of both surfaces. 2×2 surface is also used to simulate O-(or Si-, OH-, and SiH-) absorbed SiO₂ surface.

2. Calculation Details

In this work, all the calculations have been performed with density functional theory³¹. The generalized gradient approximation (GGA) is used to express the exchangecorrelation energy of interacting electrons by the parametrization of Perdew-Burke-Ernzerhof (PBE)³². With the accurate frozen-core full-potential projector augmented wave (PAW) method³³, the electron-core interaction is described as implemented in the VASP program package^{34, 35}. The *k*-space integral and plane-wave basis, as detailed below, are tested to ensure that the total energy is converged at the 1 meV/atom level. The kinetic energy cutoff of 600 eV for the plane wave expansion is found to be sufficient. For 1×1 surface, the geometry is optimized with an 8×8×2 *k* mesh. 2×2 surface is constructed based on the optimized 1×1 surface and then is optimized with a 2×2×1 *k* mesh. The self-consistent electronic structure calculations are performed with a 12×12×1 *k* mesh for 1×1 surface and a 6×6×1 *k* mesh for 2×2 surface.

Results and Discussions

1. Electronic Properties of Bulk and Surface

Before launching the calculation of surface, the electronic properties of bulk are investigated to uncover the structural and electronic properties. The calculated lattice constants a (4.848 Å) and c (5.371 Å) are similar to the experimental lattice parameters (4.913 Å and 5.405 Å), for α-quartz structure with symmetry group P3121. For cristobalite structure with symmetry group FD-3M, the obtained lattice constant is 7.363 Å. By the consideration of [111] direction, the hexagonal cell with lattice constants a (5.20 Å) and c (12.75 Å) are employed. After the optimization of structure, the electronic properties of α quartz and cristobalite structures are obtained. The calculated bands are plotted versus high-symmetry lines in hexagon-symmetry Brillouin zone. As shown in Fig. 1, cristobalite structure and α -quartz have the similar band gap. Large band gaps demonstrate their insulating property which is consistent with the previous calculation $^{36, 37}$. The difference is that the valence band edge and conduction band edge of cristobalite is at the same point (Γ point). The valence band edge of α -quartz is not at the Γ point. As mentioned in the previous study³⁸, the band gap is underestimated by DFT-GGA calculation. The exact estimation needs to perform the quasiparticle band structure calculation³⁸. However, this doesn't affect the analysis about the electronic properties of the mixed system of graphene and SiO₂ surface, as stated in the next part.

It is well known that the SiO₂ surface in most experiments is with amorphous structure. For the amorphous SiO₂, the bond lengths and bond angles have continuous distribution³⁶, without the periodic cell which makes the difficulty to simulate the surface with DFT. However, the local structures of some crystal forms of SiO₂ are similar to that of amorphous SiO₂. The crystal SiO₂ structures, such as α quartz and cristobalite, have local structures of fourfold tetrahedral bonding for Si and twofold bridging bonding for O. For α quartz, the calculated Si-O bond length and the bond angle of Si-O-Si are about 1.590 Å and 143.05°, respectively. For cristobalite, the bond length and the bond angle are about 1.594 Å and 180°, respectively. The similar local structure results in the similar electronic insulating property. In additional, the different bond angle of α quartz and cristobalite can make the different surface configurations. Therefore, it is proper to use the surfaces of α quartz and cristobalite to simulate that of amorphous SiO₂, since the local structures of amorphous surface with different dangling bonds can be simulated by the different surfaces of α quartz and cristobalite.

Now we analyze some basic configurations of SiO₂ surface. If the top surface is the oxygen or hydroxyl (OH), the Si atoms of bottom surface are passivated by hydrogen. If the top surface is silicon or SiH, the oxygen atoms of bottom surface are also passivated by hydrogen. In Fig.2, seven configurations of surface are demonstrated, based on α -quartz and cristobalite. For Si-polar surface as a local stable configuration, the Si atom is possible to have two dangle bonds (Fig. 2A) and one dangle bond (Fig. 2B and C), or no dangle bond if silicon atom is passivated by two hydrogen atom. For O-polar surface as a local stable configuration, the oxygen atom is possible to have one dangle bond (Fig. 2F), or no dangle bond if oxygen atom is passivated by one hydrogen atom. It is noticed that each oxygen pair is bonded with one silicon atom (Fig. 2D) for α -quartz (0001) surface as a simple cleaved surface. The oxygen pair may be unstable and reconstruct the surface by removing one of oxygen atoms (Fig. 2G) or be passivated by partly hydrogenating (Fig. 2E) or fully hydrogenating.

Before investigating the interaction between graphene and different configurations, we calculate the electronic properties of different surfaces. As shown in Fig. 3A, we can found that the two dangling bonds of Si atom introduce two localized bands in the region of bang gap. Since there are two isolated electrons for silicon on the surface, one of the bands is occupied fully and leave one vacant band near the conduction band edge. Therefore, it is possible to be not activated. If one electron is paired by introduction of hydrogen, the residual electron will form a typical dangle bond. The case is similar to the Si atom in the cristobalite (111) surface. There is a localized state in the center of band gap and the state is half occupied (Fig. 3B and C). In Fig. 3D, we show the band structure of O-polar surface with one oxygen pair. It is well known that each oxygen atom has an isolated electron. Two isolated electrons from two oxygen atoms interact with each other and form two separated bands in the center of band gap and one of bands is occupied. However, this case may be different from that of Si atom of surface in Fig. 3A, since the two electrons don't form a stable pair due to the large distance. If one of oxygen atoms is passivated by hydrogen, we can find that the localized state is shifted to the top of valance band and is half occupied (Fig. 3E). This case has a little different from the case of cristobalite (111) surface. As shown in Fig. 3F, there are two localized bands which are almost degenerate.

2. Absorption of Graphene on Different Surface Configurations

We first consider the graphene layer is absorbed on the O-polar surface. Fig. 4A-E shows the optimized geometric structures for different adsorption sites of surface. It is found that graphene layer keeps its plane with hexagonal network for all these cases with physical absorption, except the chemical absorption site in the potential curve (Fig. 4G) for pair oxygen configuration (Fig. 4B). For the reconstructed surface (Fig 4A), the result is similar to the previous experimental and theoretical studies ^{30, 39, 40}. The difference is that the absorption energy is smaller (about 12 meV/unit cell). From the equilibrium position of potential curve in Fig. 4F, we can found that the distance between carbon and oxygen is about 3.8 Å. It demonstrates that the reconstructed surface is very stable and the interaction between graphene and the surface is weak, as Nguyen et al. stated³⁰. There is no charge transfer between graphene and the reconstructed surface and the surface just disturbs weakly the electronic state of graphene at Dirac points to result in a small gap which even can be ignored. For (111) cristobalite surface, the distance between carbon and oxygen (about 3.0 Å) is similar at different absorption sites (Fig. C, D and E). The hexagonal center is the stablest site with absorption energy about 470 meV per unit cell, as shown in Fig. 4H. For top site of (0001) α -quartz surface with pair oxygen, the physical absorption is with equilibrium distance 3.4 Å and absorption energy 112 meV per unit cell. However, after hopping a potential barrier about 260 meV, the chemical absorption is formed with the distance between carbon and oxygen 1.55 Å, as shown in Fig. 4G. For the

chemical absorption, the carbon has a trend to drop down to form a chemical bond with oxygen atom of surface. The absorbed carbon atom deviates from the graphene plane to result in large strain energy due to the localization of absorption site. As a case, the chemical absorption at top site of (111) cristobalite surface is possible to form. However, the absorption is not stable due to the large strain energy (Fig. 4H). The same reason is for partly hydrogenated O-polar surface on which graphene just form the physical absorption. Of course, for the fully hydrogenated O-polar surface, the interaction between graphene and surface is weak, since there is no active site for chemical absorption or strong physical absorption as other author stated.

For the Si-polar surface, the optimized geometric structures for different adsorption sites of surface are shown in the Fig. 5A-E. For all the case, graphene is absorbed physically on the surface and graphene layer keeps its planar hexagonal network. The binding energy is smaller than that of the absorption on O-polar surface. For (0001) α -quartz surface, the absorption energy is about 13 meV per unit cell with equilibrium distance about 4.3 Å. For (111) cristobalite surface, the binding energies (top and bridge: 18.5 meV/unit cell; hexagonal center: 24 meV/unit cell) are little larger than that of (0001) α -quartz surface. This may be attributed to the activity of silicon atom with one dangling bond. For both surface, the hexagonal center is the stablest site, similar to the case of O-polar surface. The reason is that the charge repulsion between graphene and surface of SiO₂ is weak due to the space separation of carbons and surface atoms. In additional, on top site of (111) cristobalite surface, graphene is possible to form chemical absorption due to the activity of dangling bond of silicon atom, as shown in Fig. 5H. This case is similar to the configuration of silicon with one dangling bond on (0001) α -quartz surface due to H-termination, as stated by Kang et al.. Of course, for the fully hydrogenated Si-polar surface, the absorption is physical. In general, as the above discussion suggests, the graphene layer can be absorbed freely on SiO₂, except the special case. The interaction between both them is weak and the electronic properties of graphene are possible to be changed weakly.

3. Electronic properties of interface without/with defects

In Fig. 6, the band structures of some typical configuration of graphene absorbed on surface are demonstrated. As Fig. 6A shown, when graphene layer is absorbed physically on the O-polar (0001) α -quartz surface with pair oxygen, the band structure of graphene is not changed obviously. It is found that the vacant band from pair is occupied partly and the Fermi level is pinned at that band and electron is transferred from graphene layer to surface to result in the p-doping of graphene. If the graphene is absorbed chemically on the surface after jumping the energy barrier, the band structure of graphene is broken strongly with a large band gap (about 2.7 eV), as previously reported²⁷. If there is isolated oxygen on the surface, the localized band from oxygen will result in the shift of Fermi level, as shown in Fig. 6B. The band structure of graphene is not changed when it absorbed on bridge site of O-polar (111) cristobalite surface. The results from the top and hexagonal sites are similar to that of bridge site. For Si-polar surface, there is no charge transfer between graphene and

surface, whatever there is the nonactive Si atom with two free electrons or the active Si atom with single dangle bond on the surface. This may be attributed to the similar electronegativity of silicon on SiO₂ surface and carbon of graphene. If the surface (O-polar or Si-polar) is passivated by hydrogen, the bands from π electrons of graphene are mostly stayed in the large band gap of the surface and the electronic properties of graphene are not affected from the surface, as shown in Fig. 6C and F.

From the above analysis, the interaction between graphene and surface mostly is by physical absorption. The weak interaction doesn't break the band structure of graphene as reported in a lot of experiments. However, it is also possible to form the chemical absorption on special configuration, such as the oxygen pair configuration on O-polar surface. But previous studies showed that cleaved SiO_2 is easy to be reconstructed or hydroxylated (or hydrogenated) to eliminate the dangle bonds. Therefore, it seems to be impossible that there is large region of active surface with dangle bonds. While the oxygen and silicon defects with dangle bond is possible to appear on surface.

In Fig. 7, we give an analysis of some typical SiO₂ surfaces with defects. For oxygen defects (Fig. 7A and B) and silicon defect with one dangle bond (Fig. 7D) in the H-passivated (O-polar or Si-polar) surface, graphene layer still be absorbed physically on the surface and the active defect atom doesn't interact chemically with the carbon atom of graphene. However, the oxygen defects introduce the localized energy levels at top of valance band and result in that the Fermi level of graphene is shifted down. The charge transfer evidently induces the hole-doping of graphene. For silicon defect, there is no charge transfer and the electronic properties don't change. The defect just induces a localized level at the Dirac points. However, the electronic scattering from the defect will affect the mobility of carrier in graphene layer. Therefore, the defects result in the spatially inhomogeneous distribution of charge in graphene plane. In some special case, it is possible to appear the raised defects on the surface. In Fig. 7C and E, such the oxygen and silicon defects are demonstrated, respectively. It is found that the raised defects can form the chemical interaction with the graphene layer by dropping carbon atom down to form the C-O bond or C-Si bond. Such the defects disturb strongly the electronic properties of graphene near Dirac points and a band gap is opened obviously. The oxygen defect results in down-shift of the Fermi level of graphene and the silicon defect results in up-shift of the Fermi level. One energy level from defect is coupled with the bands from Dirac cone and the Dirac cone is broken near the coupling region.

Conclusion

The interaction between graphene and SiO_2 surface has been studied systematically by first-principles DFT calculations. Different configurations of SiO_2 surface are considered, based on α -quartz and cristobalite structures. It is found that graphene layer mostly is absorbed physically on surface and the hexagonal center site is the stablest site for both O-polar and Si-polar surface. This may be attributed to the largest spacial separation of charges to reduce the coulomb repulsion when graphene layer approaches to the region of surface due to van der Waals interactions and possible charge transfer. It is found that the absorption on O-polar surface is stronger than that on Si-polar surface. It is ascribed to the effect of charge transfer on O-polar surface which increases the electrostatic interaction between graphene and the surface. Due to the charge transfer, it is found that the graphene absorbed on O-polar surface is hole-doped, as observed on the experiments.

The H-passivated surfaces don't affect the electronic properties of graphene whatever there is O-polar surface or Si-polar surface, whereas the surface with defects will have the strong effect to the electronic properties of graphene. It is found that the oxygen defect in the surface can result in the hole-doping of graphene. The raised atom defects will interact chemically with graphene layer and disturb the band structure of π electrons. The raised oxygen results in down-shift of Fermi level of graphene and the raised silicon results in up-shift of Fermi level. Therefore, we suggest that SiO₂ surface which is used as a substrate for fabrication of graphene device should be cleaved with atomic level of planeness and then is passivated by hydrogen.

Reference

1. Allen, M. J.; Tung, V. C.; Kaner, R. B., Honeycomb Carbon: A Review of Graphene. *Chemical Reviews* **2009**, 110, (1), 132-145.

2. Geim, A. K.; Novoselov, K. S., The rise of graphene. Nature Materials 2007, 6, 183-191.

3. Castro Neto, A. H.; Guinea, F.; Peres, N. M. R.; Novoselov, K. S.; Geim, A. K., The electronic properties of graphene. *Reviews of Modern Physics* **2009**, **81**, (1), 109.

4. Zhang, Y.; Tan, J. W.; Stormer, H. L.; Kim, P., Experimental observation of the quantum Hall effect and Berry/'s phase in graphene. *Nature* **2005**, 438, 201-204.

5. Novoselov, K. S.; Geim, A. K.; Morozov, S. V.; Jiang, D.; Katsnelson, M. I.; Grigorieva, I. V.; Dubonos, S. V.; Firsov, A. A., Two-dimensional gas of massless Dirac fermions in graphene. *Nature* **2005**, 438, (7065), 197-200.

6. Avouris, P.; Chen, Z. H.; Perebeinos, V., Carbon-based electronics. *Nature Nanotechnology* **2007**, 2, 605-615.

7. Novoselov, K., Graphene: Mind the gap. Nat Mater 2007, 6, (10), 720-721.

8. Oostinga, J. B.; Heersche, H. B.; Liu, X.; Morpurgo, A. F.; Vandersypen, L. M. K., Gate-induced insulating state in bilayer graphene devices. *Nat Mater* **2008**, *7*, (2), 151-157.

9. Ohta, T.; Bostwick, A.; Seyller, T.; Horn, K.; Rotenberg, E., Controlling the Electronic Structure of Bilayer Graphene. *Science* **2006**, 313, (5789), 951-954.

10. Craciun, M. F.; RussoS; YamamotoM; Oostinga, J. B.; Morpurgo, A. F.; TaruchaS, Trilayer graphene is a semimetal with a gate-tunable band overlap. *Nat Nano* **2009**, *4*, (6), 383-388.

11. Wehling, T. O.; Novoselov, K. S.; Morozov, S. V.; Vdovin, E. E.; Katsnelson, M. I.; Geim, A. K.; Lichtenstein, A. I., Molecular Doping of Graphene. *Nano Letters* **2007**, **8**, (1), 173-177.

12. Fan, X.; Liu, L.; Kuo, J.-L.; Shen, Z., Functionalizing Single- and Multi-layer Graphene with Br and Br2. *The Journal of Physical Chemistry C* **2010**, 114, (35), 14939-14945.

13. Elias, D. C.; Nair, R. R.; Mohiuddin, T. M. G.; Morozov, S. V.; Blake, P.; Halsall, M. P.; Ferrari, A.

C.; Boukhvalov, D. W.; Katsnelson, M. I.; Geim, A. K.; Novoselov, K. S., Control of Graphene's

Properties by Reversible Hydrogenation: Evidence for Graphane. Science 2009, 323, (5914), 610-613.

14. Boukhvalov, D. W.; Katsnelson, M. I., Tuning the gap in bilayer graphene using chemical functionalization: Density functional calculations. *Physical Review B* **2008**, 78, (8), 085413.

15. Giovannetti, G.; Khomyakov, P. A.; Brocks, G.; Kelly, P. J.; van den Brink, J., Substrate-induced band gap in graphene on hexagonal boron nitride: Ab initio density functional calculations. *Physical Review B* **2007**, 76, (7), 073103.

Mattausch, A.; Pankratov, O., Ab Initio Study of Graphene on SiC. *Physical Review Letters* 2007, 99, (7), 076802.

17. Ni, Z. H.; Chen, W.; Fan, X. F.; Kuo, J. L.; Yu, T.; Wee, A. T. S.; Shen, Z. X., Raman spectroscopy of epitaxial graphene on a SiC substrate. *Physical Review B* **2008**, 77, (11), 115416.

18. Berger, C.; Song, Z.; Li, X.; Wu, X.; Brown, N.; Naud, C.; Mayou, D.; Li, T.; Hass, J.; Marchenkov, A. N.; Conrad, E. H.; First, P. N.; de Heer, W. A., Electronic Confinement and Coherence in Patterned Epitaxial Graphene. *Science* **2006**, 312, (5777), 1191-1196.

Varchon, F.; Feng, R.; Hass, J.; Li, X.; Nguyen, B. N.; Naud, C.; Mallet, P.; Veuillen, J. Y.; Berger, C.; Conrad, E. H.; Magaud, L., Electronic Structure of Epitaxial Graphene Layers on SiC: Effect of the Substrate. *Physical Review Letters* 2007, 99, (12), 126805.

Novoselov, K. S.; Geim, A. K.; Morozov, S. V.; Jiang, D.; Zhang, Y.; Dubonos, S. V.; Grigorieva, I.
V.; Firsov, A. A., Electric Field Effect in Atomically Thin Carbon Films. *Science* 2004, 306, 666-669.

21. Han, M. Y.; Ouml; zyilmaz, B.; Zhang, Y.; Kim, P., Energy Band-Gap Engineering of Graphene Nanoribbons. *Physical Review Letters* **2007**, **98**, (20), 206805.

22. Ishigami, M.; Chen, J. H.; Cullen, W. G.; Fuhrer, M. S.; Williams, E. D., Atomic Structure of Graphene on SiO2. *Nano Letters* **2007**, *7*, (6), 1643-1648.

23. Berciaud, S.; Ryu, S.; Brus, L. E.; Heinz, T. F., Probing the Intrinsic Properties of Exfoliated Graphene: Raman Spectroscopy of Free-Standing Monolayers. *Nano Letters* **2008**, *9*, (1), 346-352.

24. Romero, H. E.; Shen, N.; Joshi, P.; Gutierrez, H. R.; Tadigadapa, S. A.; Sofo, J. O.; Eklund, P. C., n-Type Behavior of Graphene Supported on Si/SiO2 Substrates. *ACS Nano* **2008**, *2*, (10), 2037-2044.

25. Ryu, S.; Liu, L.; Berciaud, S.; Yu, Y.-J.; Liu, H.; Kim, P.; Flynn, G. W.; Brus, L. E., Atmospheric Oxygen Binding and Hole Doping in Deformed Graphene on a SiO2 Substrate. *Nano Letters* **2010**, 10, (12), 4944-4951.

26. Cheng, Z.; Zhou, Q.; Wang, C.; Li, Q.; Wang, C.; Fang, Y., Toward Intrinsic Graphene Surfaces: A Systematic Study on Thermal Annealing and Wet-Chemical Treatment of SiO2-Supported Graphene Devices. *Nano Letters* **2011**, 11, (2), 767-771.

27. Kang, Y.-J.; Kang, J.; Chang, K. J., Electronic structure of graphene and doping effect on SiO2. *Physical Review B* **2008**, 78, (11), 115404.

28. Shemella, P.; Nayak, S. K., Electronic structure and band-gap modulation of graphene via substrate surface chemistry. *Applied Physics Letters* **2009**, 94, (3), 032101-3.

29. Hossain, M. Z., Chemistry at the graphene-SiO[sub 2] interface. *Applied Physics Letters* **2009**, 95, (14), 143125-3.

30. Nguyen, T. C.; Otani, M.; Okada, S., Semiconducting Electronic Property of Graphene Adsorbed on (0001) Surfaces of SiO2. *Physical Review Letters* **2011**, 106, (10), 106801.

31. Hohenberg, P.; Kohn, W., Inhomogeneous Electron Gas. Physical Review 1964, 136, (3B), B864.

32. Perdew, J. P.; Chevary, J. A.; Vosko, S. H.; Jackson, K. A.; Pederson, M. R.; Singh, D. J.; Fiolhais, C., Atoms, molecules, solids, and surfaces: Applications of the generalized gradient approximation for exchange and correlation. *Physical Review B* **1992**, 46, (11), 6671.

33. Blochl, P. E., Projector augmented-wave method. *Physical Review B* 1994, 50, (24), 17953.

34. Kresse, G.; Furthmüller, J., Efficient iterative schemes for ab initio total-energy calculations using a plane-wave basis set. *Phys. Rev. B* **1996**, 54, 11169–11186

35. Kresse, G.; Furthmüller, J., Efficiency of ab-initio total energy calculations for metals and semiconductors using a plane-wave basis set *Computat. Mater. Sci.* **1996**, 6, 15-50.

36. Li, Y. P.; Ching, W. Y., Band structures of all polycrystalline forms of silicon dioxide. *Physical Review B* **1985**, 31, (4), 2172.

37. Schneider, P. M.; Fowler, W. B., Band Structure and Optical Properties of Silicon Dioxide. *Physical Review Letters* **1976**, 36, (8), 425.

38. Ramos, L. E.; Furthm; uuml; ller, J.; Bechstedt, F., Quasiparticle band structures and optical spectra of beta -cristobalite SiO2. *Physical Review B* **2004**, 69, (8), 085102.

39. Goumans, T. P. M.; Wander, A.; Brown, W. A.; Catlow, C. R. A., Structure and stability of the (001) [small alpha]-quartz surface. *Physical Chemistry Chemical Physics* **2007**, 9, (17), 2146-2152.

40. Rignanese, G. M.; De Vita, A.; Charlier, J. C.; Gonze, X.; Car, R., First-principles molecular-dynamics study of the (0001) alpha -quartz surface. *Physical Review B* **2000**, 61, (19), 13250.



Fig. 1 The schematic structure, band structure and density of states of cristobalite (A) and α -quartz (B) structures



Fig.2 Schematic representation of the structures of seven basic SiO₂ surface: Si-polar (0001) α -quartz surface(A), Si-polar (0001) α -quartz surface with one dangling bonds per surface Si atom (B), Si-polar (111) cristobalite surface (C), O-polar (0001) α -quartz surface (D), O-polar (0001) α -quartz surface with one H-terminated oxygen (E), O-polar (111) cristobalite surface (F) and reconstructed O-polar (0001) α -quartz surface(G).



Fig.3 The band structures of the surface models of α -quartz and that of cristobalite: Si-polar (0001) α -quartz surface(A), Si-polar (0001) α -quartz surface with one dangling bonds per surface Si atom (B), Si-polar (111) cristobalite surface (C), O-polar (0001) α -quartz surface (D), O-polar (0001) α -quartz surface with one H-terminated oxygen (E) and O-polar (111) cristobalite surface (F).

Fig. 4



Fig. 4 Top views of optimized structures of graphene on O-polar surface including bridge site of reconstructed α -quartz surface (A), top site of (0001) α -quartz surface with pair oxygen and top (C), bridge (D) and hexagonal center sites (E) of (111) cristobalite surface, and potential-energy curves as a function of the oxygen atom of surface and the nearest-neighbour carbon atom of graphene including the curve (F) of configuration (A), curve (G) of configuration (B) and curves (H) of configurations (C), (D) and (E). The surface unit cell is shown by the dashed lines.

Fig. 5



Fig. 5 Top views of optimized structures of graphene on Si-polar surface including bridge (A) and hexagonal center sites of (0001) α -quartz surface and hexagonal center (C), top (D) and bridge (E) sites of (111) cristobalite surface, and potential-energy curves as a function of the oxygen atom of surface and the nearest-neighbour carbon atom of graphene including the curve (F) of configuration (A), curve (G) of configuration (B) and curves (H) of configurations (C), (D) and (E). The surface unit cell is shown by the dashed lines.

Fig.6



Fig. 6 The band structures of the mixed systems of graphene absorbed on SiO₂ surface: O-polar (0001) α -quartz surface with pair oxygen due to physical absorption on top site (A), O-polar (111) cristobalite surface with bridge site (B), H-terminated O-polar (111) cristobalite surface with bridge site (C), Si-polar (0001) α -quartz surface with bridge site (D), Si-polar (111) cristobalite surface with hexagonal center site (E) and H-terminated Si-polar (111) cristobalite surface with top site.





Fig. 7 Side and top views of optimized structures of graphene adsorbed on (0001) α -quartz surface with defect and the band structure of the mixed system including the OH surface with one oxygen (A), OH and SiH mixed surface with one oxygen (B), OH surface with one H-Si-O defect (C), SiH₂ surface with SiH defect (D) and OH surface with SiH defect (E). Blue sphere is for oxygen atom as a defect and pink sphere is for silicon atom as a defect.